

Knobbe Martens Olson & Bear LLP

Intellectual Property Law



10/608,913

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February 7, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Title: DEVICE AND METHOD OF CORRECTING EXPOSURE
DEFECTS IN PHOTOLITHOGRAPHY

Letters Patent No. 6,812,999 B2
Issued: November 2, 2004
Our Reference: MICRON.100C1

Certificate
FEB 24 2005

Dear Sir:

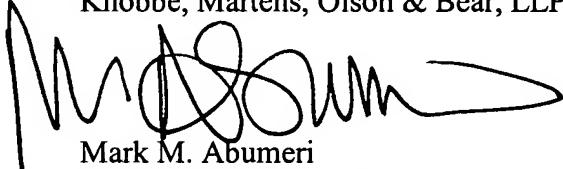
of Correction

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP



Mark M. Abumeri
Registration No. 43,458
Customer No. 20,995

Enclosure

PA-014
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020205

FEB 28 2005

Orange County
949-760-0404

San Francisco
415-954-4114

Los Angeles
310-551-3450

Riverside
951-781-9231

San Luis Obispo
805-547-5580

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,812,999 B2

DATED : November 2, 2004

INVENTOR(S): Hickman, Craig A.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title Page

Item 63, RELATED U.S. APPLICATION DATA, please delete "now abandoned" and insert -- now US Patent No. 6,727,975 --

MAILING ADDRESS OF SENDER:

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PATENT NO. 6,812,999

February 7, 2005

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